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Research Article
Mechanical Characterization of Torsional Micropaddles Using Atomic Force Microscopy

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The reference cantilever method is shown to act as a direct and simple method for determination of torsional spring constant. It has been applied to the characterization of micropaddle structures similar to those proposed for resonant functionalized chemical sensors and resonant thermal detectors. It is shown that this method can be used as an effective procedure to characterize a key parameter of these devices and would be applicable to characterization of other similar MEMS/NEMS devices such as micromirrors. In this study, two sets of micropaddles are manufactured (beams at centre and offset by 2.5 μm) by using LPCVD silicon nitride as a substrate. The patterning is made by direct milling using focused ion beam. The torsional spring constant is achieved through micromechanical analysis via atomic force microscopy. To obtain the gradient of force curve, the area of the micropaddle is scanned and the behaviour of each pixel is investigated through an automated developed code. The experimental results are in a good agreement with theoretical results.

1. Introduction

MEMS devices utilizing rotation of surfaces controlled by torsional springs have gained a lot of interest. Their use as micromirrors has led to the rapid advances in digital light processing [1]; they have been shown to act as thermal infrared detectors [2, 3] and also as resonant mass sensing devices [4, 5]. A resonant micropaddle is one such resonant torsional system and has been considered as a potential bio/chemical sensor platform [6, 7]. It can detect induced mass adsorption on its surface by measuring the frequency shift of the resonance, using the so-called mass loading effect. The first resonance mode of the supported micropaddle is torsional where the beams act like a torsional spring and the paddle rotates about this axis. Although the torsional spring constant can be calculated analytically and modelled through finite element methods, it is essential to have experimental verification of such a key parameter of the device. Experimentally, measurement of the torsional spring constant can lead to a better understanding of the mechanical behaviour of the sensor. The field of atomic force microscopy is well versed in the calibration of spring constants, albeit for cantilevers, and so it is to this field that the authors have turned for methods which apply to torsional systems.

The importance of the AFM probe’s spring constant for measuring the interaction force between the probe and sample has been recognized since its invention in 1986 [8]. The determination of probe spring constants dates back to the 1990s [9–13]. Common methods for the determination of cantilever probe spring constant are based on calculation from dimension and material properties [14], the use of a reference cantilever [15, 16], added mass [9, 17], and thermal noise analysis [18, 19].

Calculation based on cantilever dimension and modulus of elasticity is not a precise method as the dimensions are not well known and modulus of elasticity can vary from one batch to another due to different deposition conditions, specific treatment, and so forth [20]. In the added mass technique, the spring constant of a cantilever can be determined based on shift in resonance frequency due to added mass and is dependent on the effective mass and resonant frequency before and after adding the mass [9]. Spring constant
2. Fabrication

The micropaddle is fabricated from a 519 nm thick LPCVD silicon nitride membrane window (Silson Ltd., England), with a membrane size of 0.5 mm × 0.5 mm, which is supported by a 450 μm thick silicon frame of size 7.5 mm × 7.5 mm. The Young’s modulus of silicon nitride is determined to be E = 197 ± 5 GPa using nanoindentation technique [22] with assumption of the Poisson’s ratio of ν = 0.27 [23]. The micropaddle pattern is fabricated by means of Ga⁺ focused ion beam (FIB) milling, with an acceleration voltage of 30 keV and beam current of 100 pA, using a FEI Strata DB-235 FIB-SEM dual beam tool. The dimensions of the micropaddle are 8 μm × 10 μm, and it is supported via two anchored beams along its length. The beam dimensions are 1 μm × 2.5 μm, and the anchors are placed either at the centre (represented by MP-1) or offset from the centre by 2.5 μm (represented by MP-2) to give two different torsional system configurations (Figure 1).

3. Theory and Measurement Principle

In this study, an AFM cantilever (Nanosensors PPP-NCL), which was made of Si and presented a 10 nm radius of a curvature hemispherical tip, is used to measure the torsional spring constant of the micropaddle. This work was carried out using a NanoWizard II AFM (JPK Instruments, UK). Firstly, the spring constant of the AFM cantilever is calibrated using its resonance frequency, length, and width [21]. Finally, the paddle area of the micropaddle is divided into an array of 64 × 64 pixels, and the AFM cantilever is used to push the paddle at each pixel with 500 nN. The force spectroscopy data for all the points are saved and analysed to calculate the torsional spring constant using the following theory.

The micropaddle’s beam can be considered as a cantilever with rectangular cross section, as shown in Figure 2(a). Applying the torsional moment T on the beam’s free end would force it to twist by an angle θ, which is proportional to T by means of the torsional spring constant k_p (k_p = T/θ = GJ/L), where G = E/(2(1 + ν)), J, and L are the shear modulus, torsional constant, and the beam’s length, respectively. The torsional constant J for a rectangular cross section where the width, w, is greater than the thickness, t, can be expressed as follows [24]:

$$J = \frac{wt^3}{3} \left[ 1 - 0.616 \left( \frac{t}{w} \right) - 0.087 \left( \frac{t}{w} \right)^2 + 0.125 \left( \frac{t}{w} \right)^3 \right].$$

(1)

Applying a force F at a distance d from the micropaddle’s anchor along its length (Figure 2(b)) produces a torsional moment, and as a result, the micropaddle rotates by an angle θ_p.

The two supporting beams on either side of the micropaddle act as two parallel springs; so, the effective torsional spring constant can be expressed by $K_p = 2k_p = \cdots$
1.95 nN·m and is related to the torsional moment and angle of rotation as

\[ T = Fd = K_p \theta_p. \]  

(2)

Based on (1), the maximum angle of rotation and consequently displacement for the micropaddle occur when the force is applied at the furthest distance from its anchor (Figure 2(b)).

The substrate, with the micropaddle manufactured in its centre, was adhered to a glass microscope slide using a double-sided carbon sticky tape (Fisher Scientific Ltd., UK). The glass slide was immobilised onto a sample holder using spring clips. The sample holder is adhered to the AFM stage using a magnetically actuated three-point alignment system; the AFM camera image is shown in Figure 3(a).

The AFM cantilever probe is mounted on a piezo stage and is tilted by an angle \( \phi \), which is the angle between the cantilever and the horizontal axis. As the optical lever is measuring the

![Figure 3](image)

**Figure 3:** (a) AFM camera image of the micropaddle and the AFM probe. (b) Schematic of applying a torsional moment to the micropaddle using the AFM cantilever.

4. Results and Discussion

In the cantilever reference method, the AFM cantilever is tilted by an angle \( \phi \), which is the angle between the cantilever and the horizontal axis. As the optical lever is measuring the...
vertical deflection of the AFM cantilever, the effective spring constant \( k_{\text{effective}} = k/\cos^2(\phi) \) which is the perpendicular stiffness to the surface of the micropaddle needs to be used instead of its intrinsic spring constant \[13\]. In this work, \( \phi \) and \( k_{\text{effective}} \) are 10 degree and 27.65 N m\(^{-1}\).

It is worth noting that the effect of sample tilt on the measurements is negligible. The NanoWizard II AFM is a state-of-the-art measurement system, with repeatable tip/sample alignment due to the magnetically actuated three-point alignment system and the greatest source of tilt error will be due to the double-sided carbon sticky tape. Given the tape thickness (90 \( \mu \)m) and the sample dimensions (7.5 mm \( \times \) 7.5 mm), the highest possible tilt from the horizontal is expected to be less than 1 degree, which would have a negligible (<1%) impact on the data.

AFM images of the micropaddles are shown in Figure 5. JPK Data Processing software (JPK Instruments, UK) is used to measure and extract the force spectroscopy data for all scanned points on the micropaddle surface. A bespoke MATLAB code is developed to analyse the force spectroscopy data for each individual pixel. The slope \( c \) for all the pixels is calculated and presented in Figure 6.

The slope along the width almost remains constant which suggests that the micropaddle’s displacement is the same and almost independent of the position of the applied force along its width (Figure 6(c)). Figure 6(d) presents the slope for MP-1 along its length which is symmetrical around the centre. As the AFM cantilever scans the micropaddle along its length, the slope increases from one free end to the centre of rotation and decreases again when it moves away from the centre and the minimum and maximum slopes occur at its free ends and centre of rotation.

In the theoretical calculation, the beams’ anchors are fixed and when the AFM cantilever is pushed against the beam (i.e., on the torsional axis), almost no deflection is expected in the z-direction. This is due to the beams’ dimensions and the resultant spring constant in z-direction \( K_{zz,p} \), as \( K_{zz,p} \approx 2 \times (12EI_{xx}/L^3) \approx 3500 \text{ N m}^{-1} \), which is two orders of magnitude greater than the spring constant of the AFM cantilever (27.65 N m\(^{-1}\)).

If the anchors were fixed, the theoretical slope should be equal to 1 through the centre line passing through the two anchors, which means that the displacement of the cantilever tip would be equal to its end displacement. However, the anchors are found not to be completely fixed as the empirically achieved slope is \(~0.7\) which indicates that the micropaddle undergoes some vertical displacement in this region.

The torsional spring constant should remain the same through the length of the micropaddle centreline and is independent from the position where the force is applied. The theoretical slope is calculated by substituting the theoretical torsional spring constant \( (K_p = 2\times 1.95 \text{ N m}) \) of the micropaddle into (4).

The theoretical slope for MP-1 is shown in Figure 7(a). As it is presented, the slope from experiment follows the same trend, but it is offset by the difference between the maximum theoretical slope through calculation and experimental slope. The experimental values are transformed by adding the offset value to the measured experimental slope. As it is illustrated in Figure 7(a), the transformed values are in good agreement with theoretical values. The micropaddle is fabricated at the centre of a 519 nm thick, 500 \( \mu \)m \( \times \) 500 \( \mu \)m silicon nitride membrane, which is supported by a silicon frame and so is not a rigid area. The extra displacement for the micropaddle can be explained by the deflection of this membrane window.

However, for the micropaddle where the anchors are offset by 2.5 \( \mu \)m (MP-2), the transformed slope does not completely fit the theoretical slope even after applying the offset, as shown in Figure 7(b). The effect starts to be greater for distances larger than 5 \( \mu \)m from the anchor. In fact, as the distance from the anchor increases, the effect of membrane deflection reduces, since torsion becomes the dominant effect on the anchors, and so the offset does not need to be applied uniformly to all of the measured data. The effect is governed by the micropaddle torsional spring rigidity and the silicon nitride membrane compliance. It is worth noting that the effect of unbalanced weight for MP-2 on the measurements can be neglected. The mass and centre of mass for the unbalanced part are 62.28 fg (assuming silicon nitride density \( = 3000 \text{ kg m}^{-3} \) [23]) and at 5 \( \mu \)m offset from the anchors. This would consequently lead to 3.05 aN\( \cdot \)m torque on the torsional springs. The minimum and maximum torques due to the force from the AFM probe (500 nN) on the unbalanced part at corresponding offset distance of 2.5 \( \mu \)m and 7.5 \( \mu \)m from the centre of rotation are 1.25 pN\( \cdot \)m and 3.75 pN\( \cdot \)m which are almost six orders of magnitude greater compared to the added torque due to the unbalanced weight on the torsional springs. Therefore, the effect of unbalanced weight compared to the AFM probe force on the measurements is negligible.

If the nontorsional spring constant \( K_{zz,p} \) of the anchors of the micropaddle was in a comparable range as the AFM cantilever spring constant, then the slope would also be a function of distance based on the relative values of \( K_p, K_{zz,p} \) and the membrane compliance.

For MP-1 presented here, the mean torsional spring constant along the length for \( d > 1.5 \mu \text{m} \) is evaluated and is shown to be equal to 1.84 \( \pm \) 0.1 N\( \cdot \)m (Figure 8(a)). The experimental (after offsetting data) and theoretical torsional spring constants of the micropaddle are in good agreement, and the error is \(~6\%\). The torsional spring constants for
Figure 6: $8 \mu m \times 10 \mu m$ micropaddle's map of the slope over the surface for (a) MP-1 and (b) MP-2. (c) Slope $c$ along the width at the furthest edge from the anchor for MP-1. (d) Slope $c$ along the length at centre for MP-1.

Figure 7: Slope $c$ along the centreline of the micropaddle (a) for MP-1 and (b) for MP-2.
MP-2 should be the same as MP-1 since they have the same beam dimensions, are made of same material, and are fabricated by the identical technique. Transferring the data by the offset value for MP-2 and calculating the mean torsional spring, $1.86 \pm 0.2$ nN · m, along the length for $d > 1.5 \mu m$ result in $\sim 5\%$ error (Figure 8(b)). At $d > 5 \mu m$, where the transformed experimental slope and theoretical slope are not identical, as shown in Figure 7(b), the experimental torsional spring constant is seen to deviate in a linear manner from the values below $d = 5 \mu m$ (Figure 8(b)). The difference between the experimental slope and theoretical slope can be fitted linearly; therefore, the effect of membrane compliance on the experimentally observed total displacement of the micropaddle is reduced linearly at $d > 5 \mu m$ for this particular micropaddle.

5. Conclusions

In this study, the torsional spring constant of the micropaddles is shown to be able to be determined by the reference cantilever method using AFM force spectroscopy. The micropaddles are fabricated out of 519 nm thick silicon nitride membrane using FIB. The paddle area imaged by the AFM is divided into a grid of 64 × 64 pixels, with force-displacement data acquired at all points. The gradient of the force curve is used to find the mean torsional spring constant at distances greater than 1.5 $\mu m$ from the anchors. The differences from calculated values are found to be less than 6% for both micropaddles. As the anchors are not completely fixed, larger displacement compared to theory for the paddle rotation is observed which is due to the silicon nitride membrane deflection; however, the same theoretical gradient trend is observed. This indicates that the membrane deflects similarly through the micropaddle area for micropaddle with anchors at the centre. For the case when the micropaddle is part of another suspended membrane, the displacement can be considered as a function of distance from the centre and is dependent on membrane compliance and the anchors’ normal and torsional spring constant. The suitability of this method to characterize torsional microsystems has been shown, and it is clear that it can be applied to the characterization and understanding of the mechanical behaviour of micromirrors or similar structures.

Data Availability

The data used to support the findings of this study are available from the corresponding author upon request.

Conflicts of Interest

The authors declare that there is no conflict of interest regarding the publication of this paper.

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